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**AMENDMENTS TO THE CLAIMS** 

Please amend the claims as follows:

1. (PREVIOUSLY PRESENTED) A vacuum deposition apparatus

comprising:

. . .

a susceptor for heating a glass substrate, a portion of the susceptor

providing an area used as a sliding portion on which to slide the glass

substrate to a desired position;

lift pins for supporting the glass substrate;

a robot arm for transferring the glass substrate onto the susceptor and

returning the glass substrate from the susceptor, wherein the robot arm slides

the glass substrate on the sliding portion of the susceptor; and

a groove formed in said portion of the susceptor for receiving material

resulting from sliding of the glass substrate by the robot arm on the surface of

the susceptor.

2. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein a length of said sliding portion, measured from

said groove, is at least 3 mm.

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3. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 2, wherein a length of said sliding portion, measured from

said groove, is 10 mm.

. . .

4. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein the susceptor is made of a quartz material.

5. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein the section of said groove formed in said portion

of the susceptor has a polygonal configuration.

6. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein the bottom face of the groove formed in said

portion of the susceptor has a curved configuration.

7. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein the bottom face of the groove formed in said

portion of the susceptor includes an incline plane and a perpendicular plane.

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8. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein the groove formed in said portion of the

susceptor has a V-shaped configuration.

9. (CANCELED)

10. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 4, wherein the susceptor is in direct contact with the glass

substrate when the glass substrate is heated.

11. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus

according to claim 1, wherein the robot arm inclines the glass substrate with

respect to a surface of the sliding portion of the susceptor when sliding the

glass substrate.

12. (CURRENTLY AMENDED) The vacuum deposition apparatus

according to claim 1, wherein the sliding portion of the susceptor comprises:

a first planar portion;

a second planar portion vertically above the first planar portion and

horizontally contiguous with the first planar portion,

wherein the groove is formed in the second planar portion, and

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wherein the glass substrate slides on the second planar portion.

13. (WITHDRAWN) A method to position a glass substrate in a vacuum

deposition apparatus, comprising:

positioning the glass substrate above a susceptor;

lowering the glass substrate directly onto a plurality of lift pins of the

susceptor, the susceptor having a sliding portion with a groove formed in the

sliding portion;

retracting the plurality of lift pins to place the glass substrate directly on

a surface of the susceptor; and

sliding the glass substrate onto the susceptor such that any film forming

material collects in the groove of the sliding portion of the susceptor.

14. (WITHDRAWN) The method of claim 13, further comprising

inclining the glass substrate with respect to a surface of the sliding portion of

the susceptor prior to the sliding the glass substrate onto the susceptor.

15. (CURRENTLY AMENDED) The vacuum deposition apparatus

according to claim 11, wherein the robot arm is configured to be-inclined

incline the glass substrate at substantially at 85 degrees from a vertical when

sliding the glass substrate on the sliding portion of the susceptor.

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16. (PREVIOUSLY PRESENTED) The vacuum deposition apparatus according to claim 1, wherein the susceptor is rectangular.